

IN THE SPECIFICATION

Please replace the title of the application appearing at page 1, line 1, with the following rewritten title:

METHOD OF FORMING SEMICONDUCTOR DEVICE CAPACITOR BOTTOM
ELECTRODE HAVING CYLINDRICAL SHAPE OF CAPACITOR OF
SEMICONDUCTOR DEVICE AND METHOD OF FORMING THE SAME

IN THE ABSTRACT

Please replace the title of the application appearing at page 26, line 1, with the following rewritten title:

METHOD OF FORMING SEMICONDUCTOR DEVICE CAPACITOR BOTTOM
ELECTRODE HAVING CYLINDRICAL SHAPE OF CAPACITOR OF
SEMICONDUCTOR DEVICE AND METHOD OF FORMING THE SAME